## WHAT IS CLAIMED IS:

1. A method of manufacturing circuit devices, comprising:

preparing a laminated plate by laminating a first conductive film and a second conductive film via a third conductive film;

forming a conductive pattern layer by etching said first conductive film into a desirable pattern;

removing the third conductive film by use of said conductive pattern layer as a mask and thus forming anchor portions where said third conductive film is depressed further inside than said conductive pattern layer;

fixedly fitting semiconductor elements on said conductive pattern layer;

electrically connecting electrodes of said semiconductor elements with predetermined parts of said conductive pattern layer;

covering said semiconductor elements with a sealing resin layer and filling said sealing resin layer into said anchor portions; and

exposing said sealing resin layer and said third conductive film on the rear surface by removing said second conductive film.

- 2. The method of Claim 1, wherein said third conductive film is used as an etching stopper when the first conductive film is etched.
- 3. The method of Claim 2, wherein a solution containing ferric chloride or cupric chloride is used as a solution to perform said etching.
- 4. The method of Claim 1, wherein said anchor portions are formed by overetching said third conductive film by use of said conductive pattern layer as a mask.
- 5. The method of Claim 4, wherein said etching solution is an iodine-based solution.
- 6. The method of Claim 1, wherein said third conductive film is peeled off by electrolysis by use of said conductive pattern layer as a mask, and said anchor portions are formed by over-peeling.
- 7. The method of Claim 1, wherein said third conductive film and said sealing resin layer in said anchor portions remaining after entirely etching the second conductive film are exposed.

- 8. The method of Claim 7, wherein external electrodes are formed by adhering a brazing filler material to the remaining third conductive film.
- 9. A method of manufacturing circuit devices, comprising:

preparing a laminated plate by laminating a first conductive film and a second conductive film via a third conductive film;

selectively forming pads of a fourth conductive film on said first conductive film;

forming a conductive pattern layer by etching said first conductive film into a desirable pattern;

removing said third conductive film by use of the conductive pattern layer as a mask and thus forming anchor portions where said third conductive film is depressed further inside than said conductive pattern layer;

fixedly fitting semiconductor elements on said conductive pattern layer;

electrically connecting electrodes of said semiconductor elements with said pads on predetermined parts of said conductive pattern layer;

covering said semiconductor elements with a sealing resin layer and filling said sealing resin layer into said anchor portions; and

exposing said sealing resin layer and said third conductive film on the rear surface by removing said second conductive film.

- 10. The method of Claim 9, wherein said third conductive film is used as an etching stopper when the first conductive film is etched.
- 11. The method of Claim 10, wherein a solution containing ferric chloride or cupric chloride is used as a solution to perform said etching.
- 12. The method of Claim 9, wherein said anchor portions are formed by overetching said third conductive film by use of said conductive pattern layer as a mask.
- 13. The method of Claim 12, wherein said etching solution is an iodine-based solution.
- 14. The method of Claim 9, wherein said third conductive film is peeled off by electrolysis by use of said conductive pattern layer as a mask, and said anchor portions are formed by over-peeling.

- 15. The method of Claim 9, wherein said third conductive film and said sealing resin layer in said anchor portions remaining after entirely etching the second conductive film are exposed.
- 16. The method of Claim 15, wherein external electrodes are formed by adhering a brazing filler material to the remaining third conductive film.